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SERIAL NUMBER 10/606,512	FILING DATE 06/26/2003 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. 8054-23 (AW8037US/JJ)	
APPLICANTS <p>Jung-Wook Kim, Osan-si, KOREA, REPUBLIC OF; Hyeon-Deok Lee, Seoul, KOREA, REPUBLIC OF; Jin-Gi Hong, Suwon-si, KOREA, REPUBLIC OF; Ji-Soon Park, Suwon-si, KOREA, REPUBLIC OF; Eung-Joon Lee, Suwon-si, KOREA, REPUBLIC OF;</p> <p>** CONTINUING DATA <i>MR (NONE)</i></p> <p>** FOREIGN APPLICATIONS <i>MR (verified)</i> REPUBLIC OF KOREA 2002-64554 10/22/2002</p> <p>IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/16/2003</p>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> Examiner's Signature Initials		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 11	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 3
ADDRESS 22150 F. CHAU & ASSOCIATES, LLC 130 WOODBURY ROAD WOODBURY, NY 11797					
TITLE Method for cleaning a processing chamber and method for manufacturing a semiconductor device					
			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing)		